



## MAIL STOP AMENDMENT

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: R.M. Wasserman Attorney Docket No. MEIP122366  
Application No.: 10/808,948 Group Art Unit: 2625  
Filed: March 25, 2004 Examiner: Y.J. Couso  
Title: SYSTEM AND METHOD FOR EXCLUDING EXTRANEIOUS FEATURES  
FROM INSPECTION OPERATIONS PERFORMED BY A MACHINE  
VISION INSPECTION SYSTEM

### INFORMATION DISCLOSURE STATEMENT

May 31, 2005

TO THE COMMISSIONER FOR PATENTS:

Applicant is aware of the information listed in the attached form that may be material to the prosecution of the above-identified patent application.

1. X Copies of the listed non-patent literature are enclosed for the Examiner's use.
2. X Pursuant to 37 C.F.R. § 1.97(b), this Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits.
3. X The Commissioner is hereby authorized to charge any fees under 37 C.F.R. §§ 1.16, 1.17 and 1.18 which may be required during the entire pendency of the application, or credit any overpayment, to Deposit Account No. 03-1740. A copy of this document is enclosed.

Respectfully submitted,

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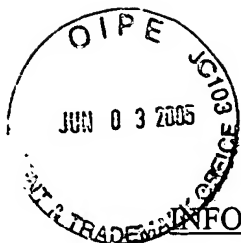
I hereby certify that this correspondence is being deposited with the U.S. Postal Service in a sealed envelope as first class mail with postage thereon fully prepaid and addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the below date.

Date:

May 31, 2005

GSF:lal

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INFORMATION CITED BY APPLICANT THAT MAY BE MATERIAL TO THE  
PROSECUTION OF THE SUBJECT APPLICATION

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U.S. PATENT DOCUMENTS

*Examiner Initials	Cite No.	Document No.	Kind Code	Date (mm/dd/yyyy)	Name
_____	U1	6,542,180	B1	04/01/2003	Wasserman et al.
_____	U2	6,627,863	B2	09/30/2003	Wasserman
_____	U3	2002/0076096	A1	06/20/2002	Silber et al.

FOREIGN PATENT DOCUMENTS

*Examiner Initial	Cite No.	Document No.	Kind Code	Publication Date (mm/dd/yyyy)	Country	English Abstract Provided	Translation Provided
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None.

OTHER INFORMATION

(Including Author, Title, Date, Pertinent Pages, Etc.)

*Examiner Initial	Cite No.	
_____	O1	Brown, L.G., "A Survey of Image Registration Techniques" <i>ACM Comp. Surv.</i> 24(4):325-376, 1992.
_____	O2	Li, H., et al., "A Model-Based Approach for Automated Feature Extraction in Fundus Images," <i>Proceedings of the Ninth IEEE International Conference on Computer Vision</i> , Nice, France, October 13-16, 2003, Vol. 1, pp. 394 ff.

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\*Examiner    Cite  
Initial        No.

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|-------|----|---|
| <hr/> | O3 | <i>QVPAK 3D CNC Vision Measuring Machine Operation Guide</i> , Version 2.0, Manual No. 4911GB, Series No. 359, Mitutoyo Corporation & Micro Encoder Inc., Kanagawa, Japan, September 1996.  |
| <hr/> | O4 | <i>QVPAK 3D CNC Vision Measuring Machine User's Guide</i> , Version 7, 1st ed., Manual No. 99MCB225A, Series No. 359, Mitutoyo Corporation & Micro Encoder Inc., Kanagawa, Japan, January 2003.   |
| <hr/> | O5 | Sasada, R., et al., "Stationary Grid Pattern Removal Using 2-Dimensional Technique for Moiré-Free Radiographic Image Display," Galloway, Robert L., Jr. (ed.), <i>Visualization, Image-Guided Procedures, and Display, Proceedings of the SPIE - The International Society for Optical Engineering, Vol. 5029</i> , San Diego, Calif., February 16-18, 2003, pp. 688-697. |
| <hr/> | O6 | Shen, J., "Inpainting and the Fundamental Problem of Image Processing," <i>SIAM News</i> 36(5):1-4, June 2003.  |

Examiner

Date Considered

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\*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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